

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>	
	10/710,300	LIU, BAO-KIM	
	<b>Examiner</b> Pierre-Michel Bataille	<b>Art Unit</b> 2186	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
711	103 ; 167	10/26/2006	PMB
711	185.3		